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To: Examiner Tu-Tu Ho	Total Pages Sent: 13
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Facsimile Number: 703-872-9306	Transmission Date: July 1, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Bao, et al. Docket No.: TSM03-0927
Serial No: 10/800,510 Art Unit: 2818
Date Filed: March 15, 2004
Title: Semiconductor Device Having a Second Level of Metallization Formed over a First Level with Minimal Damage to the First Level and Method

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- Certification of Facsimile Transmission (1 page)
- Response to Office Action (12 pages), to include:
 - Amendment (11 pages)
 - Drawing Sheet for New Figure 2g (1 page)

Respectfully submitted,


Natalie Swider
Legal Assistant

Confirmation Respectfully Requested

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For: Semiconductor Device Having a Second Level of Metallization Formed
over a First Level with Minimal Damage to the First Level and Method**RECEIVED**
CENTRAL FAX CENTER
JUL 01 2005Mail Stop: Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450**AMENDMENT**

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's

Office Action mailed April 1, 2005. Please amend the above-referenced application as follows.